



Docket No. NEC03P207-SYa
(WAK.122)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hidekazu Kawashima

Serial No.: 10/755,387

Group Art Unit: 2822

Filed: January 13, 2004

Examiner: Maria F. Guerrero

For: METHOD AND DECIDE FOR PRODUCING LAYOUT PATTERNS OF A SEMICONDUCTOR DEVICE HAVING AN EVEN WAFER.

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated January 10, 2006, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper. No new matter has been added.

Remarks begin on page 9 of this paper.